

Docket No.: 59516-052

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|-----------------------------------|---|------------------------|
| In re Application of | : | Customer Number: 20277 |
| | : | |
| Zi-Kui LIU, et al. | : | Confirmation Number: |
| | : | |
| Serial No.: | : | Group Art Unit: |
| | : | |
| Filed: February 24, 2004 | : | Examiner: |
| | : | |
| For: BORIDE THIN FILMS ON SILICON | : | |

CLAIM OF PRIORITY

Mail Stop CPD
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

U.S. Provisional Application No. 60/450,321, filed February 28, 2003.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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